

# Scan control and data acquisition with Python

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## BIOGRAPHY

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## ABSTRACT

Development of new techniques for electron microscopy often requires advances in scan control and image acquisition. A need for development may arise because of new scan patterns, new synchronisation with detectors, or simply because of high-performance resolution and speed. This article aims to provide a guide on current state of technology, with practical examples on how this control is coded from Python. It is shown here that the latest technology can already provide deep and open access to the hardware over application programmable interfaces, and that image and point map scan patterns are easy to program.

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## INTRODUCTION

For much of electron microscopy, scanning the electron beam on the sample has been fixed to the same pattern as that of scanning the electron beam inside the cathode ray tube (CRT), the display technology during the early days of microscopy. This used to provide a simple foundation for understanding magnification, as the scan size of the electron beam on the screen was fixed to the CRT physical size. This is no longer true, images can be displayed at any size, and magnification as was originally conceived does not make sense. But more importantly, whilst modern displays have inherited the CRT raster pattern from top-left to bottom-right, scanning of the electron beam on the sample can now be set free from this conventional pattern – far more is possible now, as presented here.

It should not be preconceived that scan patterns are limited the internal scan generator of the microscope.

Indeed, these have a varying degree of complexity and performance, reflecting what the manufacturer has taken as requirements at the time. There are a number of practical considerations that limit specifications and access to this internal scan generator, not only cost and service, but also compatibility with other parts of the microscope hardware and software. However, this means not that a microscope is not limited by its internal scan generator, because it may be easily bypassed with the addition of an external scan generator to the external scan interface of the microscope. This gives safe access to the internal scan amplifier, therefore enabling the electron beam to follow any external scan pattern, however complex. Typical microscope limits are given therefore by the bandwidth of its internal scan amplifier and the hysteresis of its scan coils.

This architecture is a great asset in electron microscopy, not only because it provides open means to bring new

features and value to microscopes, but also because it allows for different systems to be developed and controlled independently, not only with regards to the scan generator, but also the corresponding computer, operating system and software. We will make use of this architecture here – add an external scan generator with an open control library and use Python code to set scan parameters, map points and synchronisation signals.

## HARDWARE

The external scan generator used in this work is the sixth generation of digital imaging scanning system (DISS6) by point electronic GmbH, see Figure 1. It provides an analog interface to the microscope external scan interface, as well as a digital interface for synchronisation and signal inputs for detectors. Key interfaces will be described briefly below in order to provide the basics necessary to understand the software commands

**FIGURE 1** Photo of DISS6 scan generator hardware. To assist software development, display on front panel shows parameters of running scan job.

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In code we see there is an example where the scan generator initiates a scan by outputting a pixel trigger configured with 10 ns settling time to move the beam and 1  $\mu$ s hold time to wait for external hardware after sync input (Figure 5d).

#### STARTING SCAN AND RETRIEVING DATA

The remaining work is to start the scan job, retrieve the data in chunks until end of frame, and make the image from the pixel buffer., see example code in Figure 5c.

Note that a frame buffer array must contain corresponding addresses of the frame buffers for each channel selected – this example shows one channel only. NumPy and Image packages are used here.

#### SUMMARY AND CONCLUSIONS

The current architecture of most electron microscopes is open with regards to beam scanning and data acquisition, as it includes an external scan interface to the internal scan amplifier. This can be easily used to add an external scan generator with new functions and advanced control, with DISS6 given here as an example. Programming such equipment has become less complex over time, with the simple Python examples given here illustrating that much can be achieved with only a few code lines. DISS6 point map scan mode moves the task of scan pattern generation to the software, thus enabling an increased degree of openness towards new developments. DISS6 digital synchronisation and triggering also allows for complex synchronisation schemes with external equipment.

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```

A os.add_dll_directory(os.getcwd())
    diss6control = cdll.loadlibrary("diss6control64.dll")
    rc = diss6control.InitUSB(None)

B rc = diss6control.CreateImageScanJob(len(channels),
    byref(channels),
    byref(hScanJob))
    rc = diss6control.SetImageGeometry(hScanJob, 512, 512, 0, 0, 128, 128, 0, 0)
    rc = diss6control.SetAcquisitionTime(hScanJob, 1000)
    rc = diss6control.SetLineStartDelay(hScanJob, DISS6.TIME_SCALE_20US)
    rc = diss6control.SetBeamReturnTiming(hScanJob,
    512,
    DISS6.TIME_SCALE_10NS,
    DISS6.TIME_SCALE_10NS)
    rc = diss6control.SetFrameCount(hScanJob, 1)

C rc = diss6control.CreatePixelMapScanJob(len(channels),
    byref(channels),
    byref(hScanJob))

    for y in range(512):
        for x in range(512):
            pixels[x+y*512]=Pixel_t(PixelComponent_t(x*128, 0b1000010000000000),
            PixelComponent_t(y*128, 0))
    rc = diss6control.SetPixelMapValues(hScanJob, len(pixels), byref(pixels))
    rc = diss6control.SetFrameCount(hScanJob, 1)

D rc = diss6control.SetHardwareTriggerEnabled(hScanJob, 1, 0, 0)
    rc = diss6control.SetPixelClockLength(DISS6.TIME_SCALE_10NS)
    rc = diss6control.SetSettlingTime(hScanJob, DISS6.TIME_SCALE_10NS)
    rc = diss6control.SetHoldingTime(hScanJob, DISS6.TIME_SCALE_1US)

E rc = diss6control.StartScanJob(hScanJob, DISS6.ABORT_SCAN_IMMEDIATELY)
    while 1:
        rc = diss6control.ReadChannelData(hScanJob,
        byref(FrameBufferArray),
        byref(pixelCount),
        DISS6.READ_FLAG_USE_PIXEL_OFFSET,
        None,
        byref(pixelOffset),
        byref(status))

        if (status.value & DISS6.READ_STATUS_FRAME_END):
            break
        data = numpy.frombuffer(frameBufferA1, dtype=numpy.uint16)
        data.shape = (512,512,1)
        im = Image.fromarray(data,mode='L;16')
  
```

FIGURE 5 Example code

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